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DESCRIPTION

METHOD FOR MEASURING GAP OF LIQUID CRYSTAL CELL

TECHNICAL FIELD



159159

5 The present invention relates to a method for
measuring the gap of a liquid crystal cell filled with a
liquid crystal.

There are transmissive liquid crystal cells
illuminated with a backlight from the backside and
10 reflective liquid crystal cells utilizing natural light.
The present invention is applicable to both the transmissive
and reflective liquid crystal cells.

BACKGROUND ART

A transmissive liquid crystal cell has a structure
15 as shown in Fig. 8, where glass layers 31, 32 constitute
the uppermost layer and the lowermost layer, respectively,
and transparent electrode films 33, 34 are formed on the
inner surfaces of the glass layers 31, 32, respectively.
Furthermore, alignment films (not shown) are formed on the
20 inner surfaces of the transparent electrode films 33, 34,
which are each rubbed at a predetermined angle. A liquid
crystal 15a is sealed in between the alignment films. In
the case of a color liquid crystal cell, a color filter is
disposed on the (inner surface of the) upper glass layer
25 31.

Fig. 9 illustrates the structure of a reflective liquid crystal cell. When compared with the transmissive liquid crystal cell, this is different from the transmissive liquid crystal cell in that a reflective metal film 35 is formed in lieu of the transparent electrode 34 on one side. An alignment film is formed on the surface of the reflective metal film 35, which is rubbed at a predetermined angle.

Suppose that the thickness (cell gap) of the liquid crystal contained in a liquid crystal cell is represented by d .

There has been a conventional method for measuring the cell gap d of a liquid crystal cell, in which light is directed from above the cell without liquid crystal injected therein so that interference of light waves is measured to obtain the thickness of the air layer, which is regarded as the thickness of the liquid crystal cell (Interferometry).

However, the thickness of the air layer before injection of the liquid crystal and that of the liquid crystal cell after injection of the liquid crystal are not identical in a strict sense. Accordingly, developing a method for directly measuring the thickness of a cell after injection of a liquid crystal has been anticipated.

Another known method is a method in which the birefringence of uniaxial crystals that liquid crystals

have is utilized in such a manner that a linearly polarized component of light of a light source is introduced into a liquid crystal cell filled with a liquid crystal (hereinafter referred to as the "sample"), and the intensity
5 of the transmitted light in a cross Nicol state and the intensity of the same in a parallel Nicol state are each measured. Based on these intensities, a birefringent phase difference (which is called "retardation") of the liquid crystal is determined, from which the cell gap is obtained.
10 (Refer to H. L. Ong, Appl. Phys. Lett. 51 (18), 2 November 1987, pp1398-1400, etc.)

Incidentally, in the foregoing method, since light is directed to one side of the sample and the light that has been transmitted through the sample is measured, the light
15 source and the photodetector of the measurement system are opposed to each other with respect to the sample. For this reason, a problem arises in that the measurement system has to be large and cannot be compact in size.

In addition, since the foregoing method measures light
20 transmitted through the sample, it is inapplicable, in principle, to reflective liquid crystal cells that do not allow light to pass through.

It is therefore an object of the present invention to provide a method for measuring gap of liquid crystal cell
25 which is capable of measuring the gaps of liquid crystal

cells and applicable to both transmissive and reflective liquid crystal cells, while allowing the size of the measurement system to be compact.

DISCLOSURE OF THE INVENTION

5 (1) A method for measuring the gap of a liquid crystal cell according to the present invention comprises the following steps (a)-(e):

(a) a step of measuring a reflection intensity $S1$ in a cross Nicol state by selecting a component with a
10 polarization angle of $\theta1$ from light of a light source and introducing the component into a liquid crystal cell prepared as a sample using a polarizer, and passing light reflected from the liquid crystal cell through an analyzer;

(b) a step of measuring a reference reflection
15 intensity $Ref1$ in a condition where the analyzer is detached by selecting a component with a polarization angle of $\theta1$ from light of the light source and introducing the component into a reference using the polarizer;

(c) a step of measuring a reflection intensity $S2$ in
20 a cross Nicol state by selecting a component with a polarization angle of $\theta2$ from light of the light source and introducing the component into the liquid crystal cell using the polarizer, and passing light reflected from the liquid crystal cell through the analyzer;

25 (d) a step of measuring a reference reflection

intensity Ref2 in a condition where the analyzer is detached by selecting a component with a polarization angle of θ_2 from light of the light source and introducing the component into the reference using the polarizer; and

5 (e) a step of calculating a ratio between the measured intensities $S_1 \cdot \text{Ref2} / S_2 \cdot \text{Ref1}$ and determining the gap of the liquid crystal cell based on the ratio between the measured intensities $S_1 \cdot \text{Ref2} / S_2 \cdot \text{Ref1}$.

The "light of the light source" mentioned above may
10 be monochromatic light or polychromatic light (e.g. white light). In the case of monochromatic light, the measurement of the reflection intensity can be effected directly by a photodetector. On the other hand, in the case of polychromatic light, the measurement of reflection
15 intensity is effected by a photodetector via a spectrometer.

Since the measurement of the reference is carried out in a condition where the analyzer is detached in the step (b) above, the reference reflection intensity Ref1 includes a background component. Accordingly, an accurate value of
20 the cell gap is difficult to obtain by merely comparing the ratio between the measured intensities $S_1 / \text{Ref1}$ with a theoretically determined reflection intensity as usually done.

The present invention is therefore constituted such
25 that two kinds of polarization angles θ_1 and θ_2 are specified,

ratios between the measured intensities $S1/Ref1$, $S2/Ref2$ are determined, and the ratio $S1 \cdot Ref2 / S2 \cdot Ref1$ is calculated, thereby canceling the background component included in the reference reflection intensities.

5 Through this process, good agreement with a ratio between theoretically determined reflection intensities can be achieved, and the value of the cell gap can thus be determined accurately.

 (2) Reflection intensities at a cross Nicol state are
10 theoretically determined for a plurality of liquid crystal cells having different cell gaps with the polarization angles set to $\theta1$ and $\theta2$, and the ratio between the measured intensities $S1 \cdot Ref2 / S2 \cdot Ref1$ is compared with ratios between the theoretically determined reflection intensities
15 (theoretical intensity ratios) so that a value of cell gap corresponding to the closest theoretical intensity ratio is determined to be the gap of the liquid crystal cell.

 This method proposes a specific process that uses a plurality of liquid crystal cells in determining the gap
20 of a liquid crystal cell based on the ratio between the measured intensities $S1 \cdot Ref2 / S2 \cdot Ref1$, in which the ratio $S1 \cdot Ref2 / S2 \cdot Ref1$ is compared with theoretically determined intensity ratios.

 (3) When the reflection intensities $S1$, $Ref1$, $S2$ and
25 $Ref2$ are each measured in the form of a wavelength spectrum

and the theoretical intensities are each calculated in the form of a wavelength spectrum so that a value of cell gap that corresponds to a theoretical intensity ratio that provides the best fit curve is determined as the gap of the liquid crystal cell, the values of cell gaps can be determined more accurately.

In order to obtain wavelength spectra, light of the light source may be passed through a monochromator before it is incident on the liquid crystal cell, or light reflected by the liquid crystal cell may be passed through a spectrometer.

(4) It is preferred that the liquid crystal cell prepared as a sample is used as the reference.

In the method according to the present invention, the state of polarization of the liquid crystal cell prepared as a sample is predicted and the value of the cell gap is determined according to the prediction. When the analyzer is detached, there is no information on the state of polarization of the liquid crystal cell while the optical characteristics of the sample such as absorption characteristics are included in the reference as they are, so that influences of these optical characteristics are cancelled. The liquid crystal cell can thus be advantageously utilized as a reference.

(5) The liquid crystal cell may be a reflective liquid

crystal cell or transmissive liquid crystal cell. In the case of a transmissive liquid crystal cell, light reflected from the bottom surface is measured.

(6) It is preferred that light is incident on the liquid crystal cell at a small angle of incidence ω_1 and the light reflected from the liquid crystal cell at an angle of reflection of ω_2 is measured.

Although it is more preferable that $\omega_1 = \omega_2 = 0$ degrees, so long as $\omega_1 < 10$ degrees and $\omega_2 < 10$ degrees, reflection intensities can be measured without any problem.

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 illustrates a general configuration of a liquid crystal cell gap measurement system.

Fig. 2 illustrates optical paths of light when it is incident on a liquid crystal cell 15a and reflected from the bottom surface, and then directed outward.

Fig. 3 illustrates a general configuration of a liquid crystal cell gap measurement system where a reference is measured with the analyzer being removed.

Fig. 4 is a graph showing a result of plotting liquid crystal cell gaps d measured in a reflective mode and a transmissive mode.

Fig. 5 shows graphs where actually measured reflection intensity spectra $R_0(\lambda_i)$, $R_{45}(\lambda_i)$ are each graphed as a function of wavelength, and theoretical values of intensity

reflectance $EE^*0(\lambda)$, $EE^*45(\lambda)$ are plotted in an overlay manner.

Fig. 6 is a graph showing a result of calculation of the ratio $C_{theo}(\lambda)$ between two intensity reflectances $EE^*0(\lambda)$ and $EE^*45(\lambda)$, which is plotted together with the ratio $C(\lambda_i)$ between measured reflection intensity spectra $R0(\lambda_i)$ and $R45(\lambda_i)$.

Fig. 7 illustrates a general configuration of a liquid crystal cell gap measurement system arranged so that the angle of incidence of light incident on a liquid crystal cell 15 and the angle of reflection of the light reflected from the liquid crystal cell 15 are both 0 degrees.

Fig. 8 illustrates the structure of a transmissive liquid crystal cell.

Fig. 9 illustrates the structure of a reflective liquid crystal cell.

BEST MODE FOR CARRYING OUT THE INVENTION

1. Liquid crystal cell gap measurement system

Fig. 1 illustrates a general configuration of a liquid crystal cell gap measurement system.

The measurement system comprises a light source 11 such as a halogen lamp, an input fiber 13 for guiding light of the light source 11, a lens 12 for collimating light rays from the input fiber 13, a polarizer 14 at which light rays are linearly polarized, a liquid crystal cell 15 prepared

as a sample, an analyzer 16 for selecting linearly polarized light rays from light rays reflected from the liquid crystal cell 15, a lens 20 for converging light rays that have passed through the analyzer 16, an output fiber 17 for guiding the
5 converged light, a spectrometer 18, and a data processing apparatus 19 including a computer housed therein.

The angle of incidence ω_1 of light incident on the liquid crystal cell 15 and the angle of reflection ω_2 of light reflected from the liquid crystal cell 15 are both
10 fixed. Normally, $\omega_1 = \omega_2$ (under a total reflection condition). Preferably, ω_1 and ω_2 are within 10 degrees, and these values are set to 6 degrees in this embodiment.

The liquid crystal cell 15 may be a reflective liquid crystal cell or a transmissive liquid crystal cell. Even
15 in the case of a transmissive liquid crystal cell, light rays that are reflected from the bottom surface of the liquid crystal cell 15a are measured.

The aforementioned polarizer 14 is provided so as to be rotatable by a motor (not shown) to any desired angle.
20 The aforementioned analyzer 16 is provided so as to be rotatable by a motor (not shown) to any desired angle and in an automatically attachable and detachable manner. Let the angle of rotation of the polarizer 14 be represented by θ , and the angle of rotation of the analyzer 16 be
25 represented by γ . Since these are always used in a cross

Nicol state in the present invention, the following equation is established between them:

$$\theta = \gamma \pm 90 \text{ deg.}$$

Suppose the twist angle of the liquid crystal 15a is ϕ . Then the difference Δn between an extraordinary index of refraction n_e and an ordinary index of refraction n_o is expressed as the equation below (where ABS represents an absolute value), and the retardation is $\Delta n d$.

$$\Delta n = \text{ABS } (n_e - n_o) \quad (1)$$

Fig. 2 illustrates optical paths of light when it is incident on a liquid crystal cell 15a and reflected from the bottom surface, and then directed outward. In the present invention, the liquid crystal cell 15 is assumed to comprise two transmissive cells stacked together.

Light undergoes a twist angle ϕ and a retardation $\Delta n d$ while it passes through the inward path.

When i denotes an imaginary unit and λ denotes a wavelength of light, this phenomenon is expressed by a Jones matrix J as follows:

$$J(\phi, \Delta n d, \lambda) = \begin{pmatrix} p + i \cdot q & r + i \cdot s \\ -r + i \cdot s & p - i \cdot q \end{pmatrix} \quad (2)$$

$$\begin{aligned} \text{where } p &= \cos \phi \cos \beta + \sin \phi \sin \beta / \sqrt{1 + \alpha^2} \\ q &= \cos \phi \sin \beta \cdot \alpha / \sqrt{1 + \alpha^2} \\ r &= -\sin \phi \cos \beta + \cos \phi \sin \beta / \sqrt{1 + \alpha^2} \end{aligned}$$

$$s = \sin\phi \sin\beta \cdot \alpha / \sqrt{1+\alpha^2}$$

$$\alpha = \pi \Delta \text{nd} / \lambda \phi$$

$$\beta = \phi \sqrt{1+\alpha^2}$$

5 In addition, light undergoes a twist angle $-\phi$ and a retardation Δ nd while it passes through the outward path. The Jones matrix J to express this phenomenon is identical to the formula (2) with negated symbols of twist angle ϕ .

 The Jones matrix for the polarizer and that for the
10 analyzer are expressed as follows:

$$\text{Polarizer } (\theta) = \begin{pmatrix} \cos \theta & 0 \\ 0 & \sin \theta \end{pmatrix} \quad (3)$$

$$\text{Analyzer } (\gamma) = \begin{pmatrix} \cos \gamma & 0 \\ 0 & \sin \gamma \end{pmatrix} \quad (4)$$

15 The state of polarization of reflected light E is described as follows:

$$E = \text{analyzer}(\gamma) \cdot \text{rotator}(\phi) \cdot \text{outward path } J(-\phi, \Delta \text{nd}) \cdot$$

$$\text{rotator}(-\phi) \cdot \text{inward path } J(\phi, \Delta \text{nd}) \cdot \text{polarizer}(\theta)$$

 where the rotator (ϕ) and rotator $(-\phi)$ are operators to
20 cancel the twist that the light underwent in the liquid crystal 15a. The Jones matrix for the rotator (ϕ) is expressed as follows:

$$\text{Rotator } (\phi) = \begin{pmatrix} \cos\theta & -\sin\phi \\ \sin\theta & \cos\phi \end{pmatrix} \quad (5)$$

Intensity reflectance can be theoretically obtained by calculating EE^* . The asterisk "*" indicates that the complex conjugate is taken.

5 2. Simulation of intensity reflectance

Differences of refractive index Δn and data of twist angle ϕ of the measurement target liquid crystal at two or more wavelengths are input in the data processing apparatus 19. The angle of rotation (θ) of the polarizer 14, the angle of rotation of the analyzer 16 (γ) are set in the following two modes (a), (b):

(a) $\theta = 0$ deg., $\gamma = -90$ deg.

(b) $\theta = -45$ deg., $\gamma = -135$ deg.

With the liquid crystal cell gap d being set to a plurality of values, an intensity reflectance EE^* is calculated as a function of the wavelength λ for each of (a) and (b). These are denoted by $EE^*0(\lambda)$ and $EE^*45(\lambda)$, respectively. Then, the ratio $C_{theo}(\lambda)$ between the two intensity reflectances $EE^*0(\lambda)$ and $EE^*45(\lambda)$ is calculated:

$$20 \quad C_{theo}(\lambda) = EE^*0(\lambda) / EE^*45(\lambda)$$

The ratio $C_{theo}(\lambda)$ is displayed as a group of curves in which the liquid crystal cell gap d is the parameter.

3. Method for measuring intensity reflectance

3.1. Measurement of reference

Since there are influences included such as various characteristics of the measuring system (emission characteristics of the light source, transmittance of the optical system, sensitivity of the photodetector, wavelength characteristics of those and temporal variations of the same, etc.), and light reflection from various layers (referred to as the "background component") other than light reflection during the inward and outward travel in the liquid crystal layers, certain standardizing processing is necessary.

Generally, such standardizing processing is performed by measuring the reflection intensity of a reference and dividing a measured reflection intensity of the sample by the former.

In the present invention, the reference measuring arrangement is so constructed that the liquid crystal cell is disposed as in the sample measuring arrangement but the analyzer 16 is removed.

Fig. 3 illustrates a mode of the reference measurement.

With this arrangement, the light measured on the reference includes information on various characteristics of the measuring system, which can be eliminated from the result of measuring the sample as later described.

However, contrary to the case where the analyzer 16

is attached, because of the removal of the analyzer 16, the background component is included in this case. This background component is hereinafter denoted by Ref_b .

The light measured on the reference Ref is expressed
 5 using subscripts s and b as the sum of the component Ref_s , including information on various characteristics of the measuring system and the background component Ref_b as follows:

$$Ref_s + Ref_b$$

10 With the angle of rotation θ of the polarizer 14 set in the two modes (a) and (b) below, reflection intensities $Ref0$ and $Ref45$ of the liquid crystal cell 15 used as the reference are measured at a plurality of wavelengths λ_i (where $i=1, 2, 3, \dots, n$; n is an integer that is two or more.)

15 (a) $\theta = 0$ deg.

(b) $\theta = -45$ deg.

The reflection intensities $Ref0$ and $Ref45$ can each be expressed using subscripts s and b as follows:

$$Ref0(\lambda_i) = Ref0_s(\lambda_i) + Ref0_b(\lambda_i) \quad (6)$$

20 $Ref45(\lambda_i) = Ref45_s(\lambda_i) + Ref45_b(\lambda_i) \quad (7)$

3.2. Measurement of sample

With the liquid crystal 15 serving as the sample being placed and the analyzer 16 being attached, the angle of rotation θ of the polarizer 14 and the angle of rotation
 25 γ of the analyzer are set in the two modes (a) and (b) below,

and the reflection intensities S_0 , S_{45} of the liquid crystal cell 15 are measured at aforementioned wavelengths λ_i .

(a) $\theta = 0$ deg., $\gamma = -90$ deg.

(b) $\theta = -45$ deg., $\gamma = -135$ deg.

5 Then, the measured reflection intensities $S_0(\lambda_i)$ and $S_{45}(\lambda_i)$ are divided by the reflection intensities of the reference $Ref_0(\lambda_i)$ and $Ref_{45}(\lambda_i)$, respectively. The values resulted from the division are written as $R_0(\lambda_i)$, $R_{45}(\lambda_i)$, respectively. $R_0(\lambda_i)$ and $R_{45}(\lambda_i)$ are expressed as follows:

$$\begin{aligned} 10 \quad R_0(\lambda_i) &= S_0(\lambda_i) / Ref_0(\lambda_i) \\ &= S_0(\lambda_i) / (Ref_{0_s}(\lambda_i) + Ref_{0_b}(\lambda_i)) \quad (8) \end{aligned}$$

$$\begin{aligned} R_{45}(\lambda_i) &= S_{45}(\lambda_i) / Ref_{45}(\lambda_i) \\ &= S_{45}(\lambda_i) / (Ref_{45_s}(\lambda_i) + Ref_{45_b}(\lambda_i)) \quad (9) \end{aligned}$$

Then, the ratio $C(\lambda_i)$ between $R_0(\lambda_i)$ and $R_{45}(\lambda_i)$ is taken:

$$\begin{aligned} 15 \quad C(\lambda_i) &= R_0(\lambda_i) / R_{45}(\lambda_i) \\ &= [S_0(\lambda_i) / S_{45}(\lambda_i)] \times [(Ref_{45_s}(\lambda_i) + Ref_{45_b}(\lambda_i)) / \\ &\quad (Ref_{0_s}(\lambda_i) + Ref_{0_b}(\lambda_i))] \quad (10) \end{aligned}$$

In the second parentheses [] in the right-hand side of the ratio $C(\lambda_i)$, the background component $Ref_{45_b}(\lambda_i)$ and
20 background component $Ref_{0_b}(\lambda_i)$ are included in the numerator and denominator, respectively. When the angles ω are such small values as $\omega_1 < 10$ deg. and $\omega_2 < 10$ deg., it is possible to assume that the ratio between $Ref_{45_s}(\lambda_i)$ and $Ref_{45_b}(\lambda_i)$ and the ratio between $Ref_{0_s}(\lambda_i)$ and $Ref_{0_b}(\lambda_i)$ are
25 identical, and therefore the inside of the second

parentheses [] can be substituted with $\text{Ref}45_s(\lambda_i) / \text{Ref}0_s(\lambda_i)$.

Accordingly, by dividing $S0(\lambda_i)$ by $\text{Ref}0_s(\lambda_i)$, and dividing $S45(\lambda_i)$ by $\text{Ref}45_s(\lambda_i)$, the ratio $C(\lambda_i)$ provides a
 5 true ratio between reflection intensities of the sample where the background component is eliminated.

4. Determination of the cell gap

A graph of ratio $C(\lambda_i)$ obtained by actually measuring the liquid crystal cell 15 is fitted to graphs (which
 10 comprise a plurality of graphs using liquid crystal cell gap d as the parameter) showing ratio $C_{\text{theo}}(\lambda)$ obtained by the simulation of intensity reflectance so that the best fit cell gap d is determined. For the fitting method, a known method such as the nonlinear least squares method may be
 15 used.

5. Example

The reference angle was set to 0 deg. and the clockwise direction was defined as positive (+) angle. Reflection intensities of a twist nematic transmissive liquid crystal
 20 cell were measured by using a liquid crystal cell gap measurement system according to the present invention (reflection mode). The measurements were carried out at five positions.

The rubbing direction of the surface of the
 25 transmissive liquid crystal cell was set at -60 deg. and

the twist angle from the surface to the bottom of the cell was -240 deg.

Values of extraordinary index of refraction n_e and ordinary index of refraction n_o were known and as listed in Table 1. Index of refraction is a function of wavelength. In reality, only indices of refraction for a limited plural number of wavelengths are known. The indices of refraction for other wavelengths are interpolated by using Cauchy's formula.

The Cauchy's formula is described as follows. Where there is only data of index of refraction for one wavelength, the index of refraction is treated as a fixed value. Where there are data of index of refraction for two wavelengths, interpolation by a quadratic function of the wavelengths is performed. Where there are data of index of refraction for three wavelengths, interpolation by a quartic function of the wavelengths is performed.

[Table 1]

WAVELENGTH	450 nm	550nm	650 nm
n_e	1.6293	1.6276	1.6272
n_o	1.4849	1.4947	1.4997

The angle of rotation θ of the polarizer 14 and the angle of rotation γ of the analyzer 16 were set in the two modes (a), (b) below.

(a) $\theta = 0$ deg., $\gamma = -90$ deg.

(b) $\theta = -45$ deg., $\gamma = -135$ deg.

Then, reflection intensity spectra $R_0(\lambda_i)$ and $R_{45}(\lambda_i)$ were measured and the ratio $C(\lambda_i)$ was calculated. (See the foregoing formulae (8)-(10).)

5 Meanwhile, with the conditions being the same, an intensity reflectance EE^* of the transmissive liquid crystal cell was calculated as a function of wavelength λ . Then, the ratio $C_{theo}(\lambda)$ between the two intensity reflectances obtained in the two cases (a) and (b) was
10 calculated.

The ratio $C(\lambda)$ between actually measured values and the calculated ratio $C_{theo}(\lambda)$ were compared with each other at five points 1-5 to give liquid crystal cell gaps d at the five points 1-5.

15 Subsequently, a transmissive liquid crystal cell was situated in a cross Nicol state and a parallel Nicol state using a conventional transmissive optical system, and the intensity of transmitted light (wavelength of 550 nm) was measured at the same five points 1 -5 (transmissive mode).
20 A retardation $\Delta n d$ was determined based on the ratio between the intensities, and it was divided by the difference of refractive index Δn at a wavelength of 550 nm so as to obtain a liquid crystal cell gap d .

The liquid crystal cell gaps d obtained in the
25 reflective mode and transmissive mode described above are

listed for the individual points in Table 2.

[Table 2]

	TRANSMISSIVE MODE	REFLECTIVE MODE
POINT 1	6.275	6.269
POINT 2	6.292	6.294
POINT 3	6.331	6.321
POINT 4	6.353	6.341
POINT 5	6.424	6.406

UNIT: μm

Fig. 4 shows the result obtained when the respective liquid crystal cell gaps d measured in the reflective mode and transmissive mode were graphed. From the graph, it is obvious that the respective crystal cell gaps d obtained in the two modes are reproduced with very high correlation. The correlation coefficient R^2 when the intercept is equal to zero is 0.9802.

Subsequently, as shown in Fig. 5, actually measured reflection intensity spectra $R_0(\lambda_i)$ and $R_{45}(\lambda_i)$ at point 5 were each graphed as a function of wavelength, and theoretical values of intensity reflectance $EE^*_0(\lambda)$ and $EE^*_{45}(\lambda)$ in the two angle settings (a) and (b) were plotted and displayed in overlay.

Measured reflection intensity spectrum $R_0(\lambda_i)$: Graph A

Measured reflection intensity spectrum $R_{45}(\lambda_i)$: Graph B

Theoretical value of intensity reflectance $EE^*_0(\lambda)$: Graph

20 C

Theoretical value of intensity reflectance $EE^*_{45}(\lambda)$: Graph

D

As is apparent from Fig. 5, the measured reflection intensity spectrum $R0(\lambda_i)$ (graph A) cannot be seen as corresponding to the theoretical value $EE*0(\lambda)$ (graph C).

5 The measured reflection intensity spectrum $R45(\lambda_i)$ (graph B) cannot be seen as corresponding to the theoretical value $EE*45(\lambda)$ (graph D), either.

Subsequently, the ratio $C_{theo}(\lambda)$ between the two intensity reflectances $EE*0(\lambda)$ and $EE*45(\lambda)$ was calculated
 10 and graphed together with the ratio $C(\lambda_i)$ between actually measured reflection intensity spectra $R0(\lambda_i)$ and $R45(\lambda_i)$ as shown in Fig. 6.

$C_{theo}(\lambda)$: Graph E

$C(\lambda_i)$: Graph F

15 As is apparent from Fig. 6, the two graphs E and F correspond to each other with very good precision.

Incidentally, the tiny peak appearing around the wavelength 550 nm is considered to be a noise, because the ratio where the reflection intensity spectrum was about 0% was
 20 calculated where the peak appears.

6. Example of modification

Meanwhile, the implementation of the present invention is not limited to the foregoing embodiment. In the previous description, the angle of rotation (θ) of the
 25 polarizer 14 and the angle of rotation of the analyzer 16

(γ) are set in the two modes (a), (b) below:

(a) $\theta = 0$ deg., $\gamma = -90$ deg.

(b) $\theta = -45$ deg., $\gamma = -135$ deg.

However, the angles may be different from the above listed
 5 ones, for example, (b) above may be substituted with (b')
 below:

(b') $\theta = -30$ deg., $\gamma = -120$ deg.

In addition, while the light source 11 and
 spectrometer 18 are employed in the foregoing cell gap
 10 measurement system as means to obtain wavelength spectra,
 instead of this combination, the light source 11 and a
 monochrometer 12 may be used.

In the structures shown in Figs. 1 and 3, the angle
 of incidence ω_1 of light incident on the liquid crystal cell
 15 15 and the angle of reflection ω_2 of light reflected from
 the liquid crystal cell 15 are set to finite values other
 than 0. However, it is possible to set both of ω_1 and ω_2
 to 0 degrees.

Fig. 7 illustrates the configuration of a liquid
 20 crystal cell gap measurement system where ω_1 and ω_2 are set
 to 0 degrees.

Parallel light rays that emerge from a lens 12 are
 introduced into a liquid crystal cell 15 through a polarizer
 14 and a half mirror 21 (non-polarized beam splitter) so
 25 as to be incident normal to the liquid crystal cell 15.

Light rays reflected from the liquid crystal cell 15 pass through the half mirror 12 to be directed to an analyzer 16 and lens 20.

The aforementioned polarizer 14, half mirror 12 and
5 analyzer 16 are secured by means of a frame component 22 and are adapted to be integrally rotatable about an axis that is perpendicular to the surface of the prepared liquid crystal cell 15. Incidentally, the polarization angle of the polarizer 14 is fixed to be horizontal (perpendicular
10 to the length of the sheet), and the polarization angle of the analyzer 16 is fixed to be horizontal (parallel to the length of the sheet). The analyzer is detachable.

With this arrangement, the angle of incidence of light incident on the liquid crystal cell 15 and the angle of
15 reflection of light reflected from the liquid crystal cell 15 can be both kept at 0 degrees.

Claims

1. A method for measuring the gap of a liquid crystal cell comprising:

(a) a step of measuring a reflection intensity S_1 in
5 a cross Nicol state by selecting a component with a polarization angle of θ_1 from light of a light source and introducing the component into a liquid crystal cell prepared as a sample using a polarizer, and passing light reflected from the liquid crystal cell through an analyzer;

10 (b) a step of measuring a reference reflection intensity Ref_1 in a condition where the analyzer is detached by selecting a component with a polarization angle of θ_1 from light of the light source and introducing the component into a reference using the polarizer;

15 (c) a step of measuring a reflection intensity S_2 in a cross Nicol state by selecting a component with a polarization angle of θ_2 from light of the light source and introducing the component into the liquid crystal cell using the polarizer, and passing light reflected from the liquid
20 crystal cell through the analyzer;

(d) a step of measuring a reference reflection intensity Ref_2 in a condition where the analyzer is detached by selecting a component with a polarization angle of θ_2 from light of the light source and introducing the component into
25 the reference using the polarizer; and

(e) a step of calculating a ratio between the measured intensities $S1 \cdot \text{Ref2}/S2 \cdot \text{Ref1}$ and determining the gap of the liquid crystal cell based on the ratio between the measured intensities $S1 \cdot \text{Ref2}/S2 \cdot \text{Ref1}$.

5 2. The method for measuring the gap of a liquid crystal cell according to claim 1, wherein

reflection intensities at a cross Nicol state are theoretically determined for a plurality of liquid crystal cells having different cell gaps with the polarization
10 angles set to $\theta 1$ and $\theta 2$; and

the ratio between measured intensities $S1 \cdot \text{Ref2}/S2 \cdot \text{Ref1}$ is compared with ratios between the theoretically determined reflection intensities so that a value of cell gap corresponding to the closest theoretical intensity
15 ratio is determined to be the gap of the liquid crystal cell.

3. The method for measuring the gap of a liquid crystal cell according to claim 2, wherein

the reflection intensities $S1$, Ref1 , $S2$, and Ref2 are each measured in the form of a wavelength spectrum and the
20 theoretical intensities are each calculated in the form of a wavelength spectrum so that a value of cell gap corresponding to a theoretical intensity ratio that provides the best fit curve is determined to be the gap of the liquid crystal cell.

25 4. The method for measuring the gap of a liquid crystal

cell according to claim 1, wherein the liquid crystal cell prepared as a sample is used as the reference.

5. The method for measuring the gap of a liquid crystal cell according to claim 1, wherein the liquid crystal cell
5 is a reflective liquid crystal cell.

6. The method for measuring the gap of a liquid crystal cell according to claim 1, wherein the liquid crystal cell is a transmissive liquid crystal cell.

7. The method for measuring the gap of a liquid crystal
10 cell according to claim 1, wherein light is introduced to be incident at an angle of ω_1 on the liquid crystal cell prepared as a sample and light that is reflected from the liquid crystal cell at a reflection angle of ω_2 is measured.

8. The method for measuring the gap of a liquid crystal
15 cell according to claim 7, wherein $\omega_1 < 10$ deg. and $\omega_2 < 10$ deg.

9. The method for measuring the gap of a liquid crystal cell according to claim 7, wherein $\omega_1 = 0$ deg. and $\omega_2 = 0$ deg.